

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	4	((("6388359") or ("5909078"))).PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:29
S2	907	(216/2).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:41
S3	911	(216/52).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:41
S4	89	S2 and beam and mems	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:44
S5	7	S3 and beam and mems	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:41
S6	113	((beam or switch) and \$3stable). clm. and mems	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/16 16:51
S7	145	((beam or switch) and \$3stable). clm. and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 09:45
S8	1	((beam or switch) and \$3stable) and (micromechanical or microelectromechanical or mems)	JPO	OR	OFF	2005/02/03 15:57
S9	157	((beam or switch or spring) and \$3stable).clm. and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 16:00
S10	1189	(438/22).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:56

S11	701	(438/48).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:57
S12	497	(438/57).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 15:57
S13	1815	actuator and (\$3stable) and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 16:01
S15	267	actuator and (bistable or bi-stable) and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 16:11
S16	136	actuator.clm. and (bistable or bi-stable) and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/16 16:53
S17	131	S15 not S16	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/03 16:11
S18	173	((beam or switch or spring or actuator) and \$3stable).clm. and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:52
S19	267	actuator_and (bistable or bi-stable) and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 09:44
S20	32	(S18 or S19) and silicon-on-insulator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 09:46
S22	6	zippering with actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:03

S23	78	zipper with actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:03
S24	3	thermal adj impact adj actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:04
S25	1411	thermal adj actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:04
S26	451	(thermal adj actuator) and \$3stable	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:04
S27	336	(thermal adj actuator) and \$3stable and MEMS	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:05
S28	51	S27 not (nozzle or inkjet or (ink-jet) or (ink adj jet))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:06
S29	54	(S18 or S19) and (height with width)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:12
S30	195	(S18 or S19) and (dimensions)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:12
S31	121	(S18 or S19) and (stop)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/14 10:13
S32	52	((microswitch or micro-switch) and \$3stable).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/16 16:51

S33	628	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/16 16:54
S34	98	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam) and (silicon-on-insulator)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:19
S35	81	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam) and (silicon-on-insulator) and (etch\$3 or \$5lithography or lithographically)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:20
S36	7788	(beam or switch or spring or actuator) with (bistable or bi-stable)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:53
S37	3531	((beam or switch or spring or actuator) near2 (bistable or bi-stable))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:54
S38	906	((beam or switch or spring or actuator) near2 (bistable or bi-stable)).ab.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:54
S39	798	((beam or switch or spring or actuator) near2 (bistable or bi-stable)).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:54
S40	1583	S38 or S39	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:54
S41	57	S40 and (etch\$3 or lithograph\$6 or silicon-on-insulator)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 17:55

S42	178	((beam or switch or spring or actuator) and \$3stable).clm. and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:14
S43	273	actuator and (bistable or bi-stable) and (micromechanical or microelectromechanical or mems)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:14
S44	266	(S42 or S43) and etch\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:14
S46	24	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam) and (boundary adj condition\$1) and bearing\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:21
S47	48	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam) and (boundary adj condition\$1) and spring\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:21
S48	113	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam) and (boundary adj condition\$1) and fixed	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:21
S49	12	((bistable or bi-stable) same (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam)) and (boundary adj condition\$1) and bearing\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 18:22
S50	2	("5994816").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 19:31
S51	2	("6388359").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 19:00

S52	2	("6828887").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 19:32
S53	160	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or actuator or microswitch or beam or microbeam) and (boundary adj condition\$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 12:43
S54	100	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam) and (silicon-on-insulator)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:21
S55	100	(bistable or bi-stable or multistable or multi-stable) and (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam) and (silicon-on-insulator)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:20
S56	5413	(bistable or bi-stable) and (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam) and (stop or stopping)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:22
S57	1071	(bistable or bi-stable).clm. and (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam).clm. and (stop or stopping)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:22
S58	925	(bistable or bi-stable) near2 (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam) and (stop or stopping)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:22

S59	283	((bistable or bi-stable) near2 (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam)).clm. and (stop or stopping)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:56
S60	12	((bistable or bi-stable) near2 (micromechanical or microelectromechanical or mems or switch or spring or microspring or actuator or microactuator or microswitch or beam or microbeam)).clm. and (height with width)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/09 13:56